



Attorney Docket No: 0492611-0543/MIT9277CON1

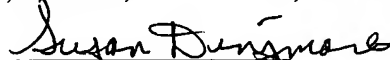
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Seleznev, *et al* Examiner: To be assigned  
Serial No.: 10/799,436 Art Unit: 1751  
Filing Date: March 12, 2004  
Title: VACUUM PROCESSING FOR FABRICATION OF  
SUPERCONDUCTING THIN FILMS FABRICATED BY METAL-  
ORGANIC PROCESSING

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on February 25, 2005.

  
Susan Dinsmore

Sir:

**Preliminary Amendment**

**Amendments to the Claims** are reflected in the listing of claims that begins on page 2 of this paper.

**Remarks** begin on page 8 of this paper.